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				Application Number		
				Filing Date		
				First Named Inventor Chakravarthi et al.		
				Group Art Unit		
Examiner Name				Attorney Docket No. TI-33161		
Sheet	1	of	1			

JP 101 U.S. PTO
10/020813
12/12/01

U.S. PATENT DOCUMENTS

Exam. Initials*	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Doc.	Date of Pub. of Cited Doc. (mm-dd-yyyy)	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (if known)			
JP	AA	6,037,640	B1	Lee	03/14/2000	Entire Document
	AB					
	AC					
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FOREIGN PATENT DOCUMENTS

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OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS

Exam. Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
JP	CA	"Modeling Solid Source Boron Diffusion for Advanced Transistor Applications", P. PACKAN, S. THOMPSON, E. ANDIDEH, S. YU, M. GILES, J SANDFORD and M. BOHR, 1998 IEEE, IEDM 98-505, 4 Pages.	
JP	CB	"Effect of fluorine on the diffusion of boron in ion implanted Si", Applied Physics Letters, 1998 American Institute of Physics, DANIEL F. DOWNEY, JUDY W. CHOW, EMI ISHIDA and KEVIN S. JONES, Volume 73, Number 9, August 31, 1998, 3 Pages.	
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Examiner Signature		Date Considered	9/18/02
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